



IPW

PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

February 6, 2007

Applicant: Hozumi TANAKA

For: METHOD OF AND APPARATUS FOR MOLDING A POLARIZING FILM

Serial No.: 10/674 169

Group: 1732

Confirmation No.: 1955

Filed: September 29, 2003

Examiner: Huson

Atty. Docket No.: 4410.P0626US

Commissioner for Patents

P.O. Box 1450

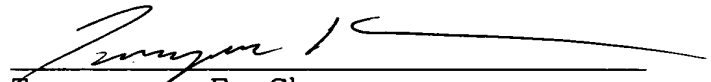
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the restriction requirement dated January 23, 2007, Applicant elects Group I, Claim 1, with traverse. The Examiner is respectfully requested to reconsider the restriction requirement as a search for the elected invention would necessarily entail a search for the non-elected invention. Favorable consideration is respectfully solicited.

Respectfully submitted,


Terryence F. Chapman

TFC/smd

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231 on February 6, 2007.


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